IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/675,419

Art Unit: 1756

Applicant: John M. Kulp

Title: SACRIFICIAL SURFACTANATED PRE-WET FOR DEFECT

REDUCTION IN A SEMICONDUCTOR PHOTOLITHOGRAPHY

DEVELOPING PROCESS

Attorney Docket: CT-001 Confirmation No.: 6182

Cincinnati, OH July 21, 2006

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

AMENDMENT - AFTER NON-FINAL REJECTION

This paper is responsive to the Office Action mailed February 21, 2006. The Examiner has indicated that claims 1-36 are pending in the application, claims 1-35 are rejected and claim 36 is withdrawn from consideration. The present response includes the following:

Amendments to the Specification: None

Amendments to the Claims: Pages 2-9

Amendments to the Abstract: None

Amendments to the Drawings: None

Remarks: Pages 10-13

Attachments: None